



IFW
PATENT APPLICATION

Date December 16, 2005

In re the Application of

Masatake NAKANO

Group Art Unit: 2812

Application No.: 10/500,381

Examiner: S. ISAAC

Filed: June 29, 2004

Docket No.: 120164

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired September 16, 2005, an extension of time for a period of three months is hereby requested. Attached hereto is our Check No. 174190 in the amount of \$1020 in payment for:

<u> </u>	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
<u> </u>	Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
<u> X </u>	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

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Respectfully submitted,

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WPB:AMC/rav

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
